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## INFORMATION DISCLOSURE STATEMENT

Applicants: Hisashi OHTANI et al.

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Group Art Unit: 2879

## U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	Subclass	Filing Date (if appropriate)
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NB	Inventors Shunpei YAMAZAKI et al., "Crystalline Semiconductor Thin Film, Method of Fabricating the Same, Semiconductor Device, and Method of Fabricating the Same", Filing Date: July 13, 1999, Specifications and Drawings for US Patent Application Serial No. 09/352,362
	Inventors Shunpei YAMAZAKI et al., "Crystalline Semiconductor Thin Film, Method of Fabricating the Same, Semiconductor Device, and Method of Fabricating the Same", Filing Date: July 13, 1999, Specifications and Drawings for US Application Serial No. 09/352,373
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Examiner

Date Considered

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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